

New PCT National Phase Application
Docket No. 2691-000058/US

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant(s): Yoshiharu OHTA et al.
Int'l App. No.: PCT/JP2005/005769
Application No.: **NEW APPLICATION**
Filed: September 28, 2006
For: SEMICONDUCTOR POLISHING COMPOSITION
(as amended)

PRELIMINARY AMENDMENT

Customer Service Window
Randolph Building
401 Dulany Street
Alexandria, VA 22314
Mail Stop PCT

September 28, 2006

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application. Prior to examination of the present application, please consider the following:

Amendments to the Title begin on page 2 of this Preliminary Amendment.

Amendments to the Abstract begin on page 3 of this Preliminary Amendment.

Amendments to the Specification begin on page 4 of this Preliminary Amendment.

Amendments to the Claims begin on page 5 of this Preliminary Amendment.

	Claims remaining after Amendment		Highest number previously paid for		Present extra
Total	8	-	20	=	0
Independent	1	-	3	=	0

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IN THE TITLE

Please ensure the title reads as follows:

"SEMICONDUCTOR POLISHING COMPOSITION"